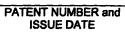
10/086497 02/26/03



U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS /56 /38	SUBCLASS	GAU .	1763 EXAMINER .	- {
10086497	02/28/2002	438	345.9=	2812	F. 12/201380	
**APPLICANTS: Yeom Geun-Young; Chung Min-Jae; Lee Do-Haing; Cho						
Sung-Min; Chung Sae-Hoon;						
						-
***	0 DATA VEDIELE					
**CONTINUING DATA VERIFIED:						
						-
						-
						∦
						-
ll	PPLICATIONS VE KOREA 2001-738		/2001			
KEF OBEIG OF	NONEA 2001-730	01 11/20	72001			-
L			-122 -2 -1.			
PG-PUB DO N	OT PUBLISH		RESCIN	ID 🗀		
Fooign priority clai	med	☐ yes	no no		ATTORNEY DOCKET NO	
35 USC 119 condit Verified and Ackno		•	i 🗖 no		YPL-0027	
Verified and Acknowledged Examiners's initials TITLE: Layer-by-layer etching apparatus using neutral beam and etching method using the same						
			-		U.S. DEPT. OF COMM./PAT & TM-P10-436L(Rev.)	2-94)

NOTICE OF ALLOWANCE MAILED			CLAIMS ALLOWED				
		Assistant Examiner	Total Claims		Print Claim for O.G		
ISSUE FEE			DRAWING				
Amount Due	Date Paid		Sheets Drwg.	Figs.Drw	g. Print F	ig.	
	<u> </u>	Primary Examiner		<u> </u>		-	
TERMINAL		PREPARED FOR ISSUE	Application Examiner				
	DISCLAMER	WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					
					_		

FILED WITH:	DISK (CRF)	CD-ROM
		ocket on right inside flag